

DECLARATION FOR PATENT APPLICATION

01S1694

COPY

As a below named inventor, I declare:
that I verily believe myself to be the original, first and sole (if only one individual inventor is listed below) or an original, first and joint inventor (if more than one individual inventor is listed below) of the invention in

SEMICONDUCTOR DEVICE FORMED IN SEMICONDUCTOR LAYER ARRANGED ON SUBSTRATE WITH ONE OF INSULATING FILM AND CAVITY INTERPOSED BETWEEN THE SUBSTRATE AND THE SEMICONDUCTOR LAYER

the specification of which is attached hereto unless the following box is checked.

☐ was filed on _____ as United States Application or PCT International Application No. _____, and was amended on _____ (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information of which is material to patentability as defined in 37 CFR 1.56.

I hereby claim foreign priority benefits under 35 U.S.C. 119(a)-(d) or 365 (b) of any foreign application(s) for patent or inventor's certificate, or 35 U.S.C. 365(a) of any PCT International application which designated at least one country other than the United States, listed below and have also identified below any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application on which priority is claimed:

<u>Country</u>	<u>Category</u>	<u>Application No.</u>	<u>Filing Date</u>	<u>Priority Claim</u>
Japan	Patent	2001-398184	December 27, 2001	Yes

I hereby appoint the registrants of Oblon, Spivak, McClelland, Maier & Neustadt, P.C., Fourth Floor, 1755 Jefferson Davis Highway, Arlington, Virginia 22202, Customer No. 22850, or any one of them, Send correspondence to Oblon, Spivak, McClelland, Maier & Neustadt, P.C., Fourth Floor, 1755 Jefferson Davis Highway, Arlington, Virginia 22202, Telephone No. (703) 413-3000.

I declare further that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

DECLARATION FOR PATENT APPLICATION

I declare further that my mailing address is at c/o
Intellectual Property Division, KABUSHIKI KAISHA TOSHIBA, 1-1 Shibaura
1-chome, Minato-ku, Tokyo 105-8001, Japan; and
that my citizenship and residence are as stated below next to my name:

Inventor: (Signature)

Date

Residence

Date: MAR. - 1. 2002

Tsutomu Sato
Tsutomu Sato

Citizen of: Japan

Yokohama-shi, Japan

Date: MAR. - 1. 2002

Hajime Nagano
Hajime Nagano

Citizen of: Japan

Yokohama-shi, Japan

Date: MAR. - 1. 2002

Ichiro Mizushima
Ichiro Mizushima

Citizen of: Japan

Yokohama-shi, Japan

Date: MAR. - 1. 2002

Takashi Yamada
Takashi Yamada

Citizen of: Japan

Ebina-shi, Japan

Date: MAR. - 1. 2002

Yuso Udo
Yuso Udo

Citizen of: Japan

Chofu-shi, Japan

Date: MAR. - 1. 2002

Shinichi Nitta
Shinichi Nitta

Citizen of: Japan

Yokohama-shi, Japan

Date:

Citizen of: Japan

Date:

Citizen of: Japan